

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No.: 10/565036 Confirmation No.: 7066  
Applicant: BECKER, *et al.*  
Filed: 18/JAN/2006  
TC/A.U.: 2829  
Examiner: Hung, Ming Hung  
Docket No.: DC5146 PCT1  
Customer No.: 00137  
Date: 10 October 2008  
For: Method for Etching a Patterned Silicone Layer

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the office action dated 20 August 2008 please amend the above-identified application as follows.

**Amendments to the Specification** are on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 7 of this paper.